

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: )  
 NISHIMOTO et al ) Group Art Unit: 2814  
 Serial No.: 08/897,839 ) Examiner: K. Eaton  
 Filed: July 21, 1997 ) VIA FACSIMILE  
 For: STRESS-ADJUSTED INSULATING ) 703 308 7722  
 FILM FORMING METHOD, )  
 SEMICONDUCTOR DEVICE AND )  
 METHOD OF MANUFACTURING THE )  
 SAME )

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 2.3

FAX COPY RECEIVED  
 MAY 23 2000  
 TECHNOLOGY CENTER 2800

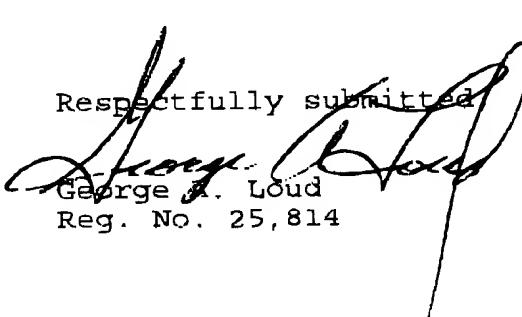
Assistant Commissioner for Patents  
 Washington, D.C. 20231

Sir:

It is respectfully requested that the time period for filing a response to the office action of February 3, 2000, initially set to expire May 3, 2000, be extended one month up to and including June 3, 2000. Please charge the requisite \$110.00 fee for the requested extension to our deposit account number 12-2174.

Any additional fees may also be charged to our Deposit Account No. 12-2174.

Respectfully submitted

  
 George A. Loud  
 Reg. No. 25,814

05/24/2000 AFORD 00000001 122174 08897839  
 01 FC:113 Pated: May 23, 2000  
 110.00 CH

LORUSSO & LOUD  
 3137 Mt. Vernon Avenue  
 Alexandria, VA 22305  
 (703) 739-9393